Sue Ann Bidstrup Allen

List of Publications by Citations

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37
papers

822
citations

15
papers

899
ext. papers

899
ext. citations

15
g-index

3.3
avg, IF

L-index

#	Paper	IF	Citations
37	Functionalized polynorbornene dielectric polymers: Adhesion and mechanical properties. <i>Journal of Polymer Science, Part B: Polymer Physics</i> , 1999 , 37, 3003-3010	2.6	128
36	Fabrication of microchannels using polycarbonates as sacrificial materials. <i>Journal of Micromechanics and Microengineering</i> , 2001 , 11, 733-737	2	78
35	Biodegradable magnesium/iron batteries with polycaprolactone encapsulation: A microfabricated power source for transient implantable devices. <i>Microsystems and Nanoengineering</i> , 2015 , 1,	7.7	59
34	Porous Methylsilsesquioxane for Low-k Dielectric Applications. <i>Electrochemical and Solid-State Letters</i> , 2001 , 4, F25		55
33	Crosslinking and decomposition reactions of epoxide functionalized polynorbornene. Part I. FTIR and thermogravimetric analysis. <i>Journal of Applied Polymer Science</i> , 2003 , 89, 568-577	2.9	43
32	Chemically Bonded Porogens in Methylsilsesquioxane. <i>Journal of the Electrochemical Society</i> , 2002 , 149, F161	3.9	43
31	Plasma Treatment and Surface Analysis of Polyimide Films for Electroless Copper Buildup Process. Journal of the Electrochemical Society, 2005 , 152, F162	3.9	40
30	Improved fabrication of micro air-channels by incorporation of a structural barrier. <i>Journal of Micromechanics and Microengineering</i> , 2005 , 15, 35-42	2	31
29	Low-Temperature Bonding of Copper Pillars for All-Copper Chip-to-Substrate Interconnections. <i>Electrochemical and Solid-State Letters</i> , 2006 , 9, C192		30
28	Fabrication of Microchannels Using Polynorbornene Photosensitive Sacrificial Materials. <i>Journal of the Electrochemical Society</i> , 2003 , 150, H205	3.9	26
27	Chemically Bonded Porogens in Methylsilsesquioxane. <i>Journal of the Electrochemical Society</i> , 2002 , 149, F171	3.9	23
26	Electroless Deposition of Copper on Organic and Inorganic Substrates Using a Sn/Ag Catalyst. Journal of the Electrochemical Society, 2012 , 159, D386-D392	3.9	22
25	Photosensitive polynorbornene based dielectric. I. Structureproperty relationships. <i>Journal of Applied Polymer Science</i> , 2004 , 91, 3023-3030	2.9	21
24	Comparison of plasma chemistries and structure-property relationships of fluorocarbon films deposited from octafluorocyclobutane and pentafluoroethane monomers. <i>Journal of Vacuum Science & Technology an Official Journal of the American Vacuum Society B, Microelectronics</i>		18
23	Processing and Phenomena, 2001 , 19, 439 Aqueous-Develop, Photosensitive Polynorbornene Dielectric: Properties and Characterization. Journal of Electronic Materials, 2009 , 38, 778-786	1.9	16
22	A MEMS-enabled biodegradable battery for powering transient implantable devices 2014,		15
21	Adhesion Enhancement Between Electroless Copper and Epoxy-based Dielectrics. <i>IEEE Transactions on Advanced Packaging</i> , 2009 , 32, 758-767		15

(2019-2008)

20	All-Copper Chip-to-Substrate Interconnects Part II. Modeling and Design. <i>Journal of the Electrochemical Society</i> , 2008 , 155, D314	3.9	15	
19	. Journal of Microelectromechanical Systems, 2014 , 23, 1281-1289	2.5	13	
18	Photosensitive polynorbornene based dielectric. II. Sensitivity and spatial resolution. <i>Journal of Applied Polymer Science</i> , 2004 , 91, 3031-3039	2.9	12	
17	Dual capacitor technique for measurement of through-plane modulus of thin polymer films. <i>Journal of Polymer Science, Part B: Polymer Physics</i> , 2000 , 38, 1634-1644	2.6	12	
16	In situ measurement of the thermal expansion behavior of benzocyclobutene films. <i>Journal of Polymer Science, Part B: Polymer Physics</i> , 1999 , 37, 311-321	2.6	12	
15	Air-Gaps for High-Performance On-Chip Interconnect Part I: Improvement in Thermally Decomposable Template. <i>Journal of Electronic Materials</i> , 2008 , 37, 1524-1533	1.9	11	
14	Crosslinking and decomposition reactions of epoxide-functionalized polynorbornene. II. Impact of reactions on mechanical properties. <i>Journal of Applied Polymer Science</i> , 2004 , 91, 1020-1029	2.9	11	
13	Lithographic Characteristics and Thermal Processing of Photosensitive Sacrificial Materials. <i>Journal of the Electrochemical Society</i> , 2002 , 149, G555	3.9	11	
12	Hydrophobic/hydrophilic surface modification within buried air channels. <i>Journal of Vacuum Science</i> & Technology an Official Journal of the American Vacuum Society B, Microelectronics Processing and Phenomena, 2004 , 22, 953		10	
11	Photodefinable Epoxycyclohexyl Polyhedral Oligomeric Silsesquioxane. <i>Journal of Electronic Materials</i> , 2010 , 39, 149-156	1.9	9	
10	Photoinitiation systems and thermal decomposition of photodefinable sacrificial materials. <i>Journal of Applied Polymer Science</i> , 2003 , 88, 1186-1195	2.9	9	
9	UV-induced porosity using photogenerated acids to catalyze the decomposition of sacrificial polymers templated in dielectric films. <i>Journal of Materials Chemistry</i> , 2007 , 17, 873-885		7	
8	Air-Gaps for High-Performance On-Chip Interconnect Part II: Modeling, Fabrication, and Characterization. <i>Journal of Electronic Materials</i> , 2008 , 37, 1534-1546	1.9	6	
7	Model-assisted development of microfabricated 3D Ni(OH) 2 electrodes with rapid charging capabilities. <i>Journal of Power Sources</i> , 2017 , 358, 101-111	8.9	5	
6	Imprint lithography enabling ultra-low loss coaxial interconnects. <i>Microelectronic Engineering</i> , 2011 , 88, 240-246	2.5	5	
5	Electron-beam hardening of thin films of functionalized polynorbornene copolymer. <i>Journal of Electronic Materials</i> , 2006 , 35, 1112-1121	1.9	4	
4	Enhanced photo-patterning of polymer dielectrics via imprint lithography. <i>Microelectronic Engineering</i> , 2012 , 93, 19-26	2.5	3	
3	3D lithium ion battery fabrication via scalable stacked multilayer electrodeposition. <i>Journal of Micromechanics and Microengineering</i> , 2019 , 29, 055006	2	2	

Vertically integrated high voltage Zn-Air batteries enabled by stacked multilayer electrodeposition.

Journal of Power Sources, 2020, 449, 227566

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Functionalized polynorbornene dielectric polymers: Adhesion and mechanical properties **1999**, 37, 3003

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